

<b>Notice of References Cited</b>	Application/Control No. 10/651,695	Applicant(s)/Patent Under Reexamination ZANZIG ET AL.	
	Examiner Rip A. Lee	Art Unit 1713	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,071,995 A	06-2000	Labauze, Gerard	524/269
	B	US-2003/0078335 A1	04-2003	Hogan et al.	524/492
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N	JP 2001-98115 A	04-2001	Japan	Nakamura	C08L 9/06
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	JP 2001-98115 (abstract in English)
	V	KR 2001-17712 A, March 5, 2001 (abstract in English only)
	W	
	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
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